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PATENT NUMBER and
ISSUE DATE

U.S. UTILITY Patent Application

APPL NUM	FILING DATE	CLASS	SUBCLASS	GAU	EXAMINER
10026378	12/21/2001	118	715	1762	Padgett

****APPLICANTS:** Chou Jing-Pei; Kao Chien-Teh; Lai Chiukin; Mosely Roderick; Chang Mei; Chen Fufa;

****CONTINUING DATA VERIFIED:**
THIS APPLICATION IS A CIP OF 08/808,246 02/28/1997
AND IS A CIP OF 08/498,990 07/06/1995 ABN
AND IS A CIP OF 08/567,461 12/05/1995 ABN
AND IS A CIP OF 08/677,185 07/09/1996 PAT 6,155,198
AND IS A CIP OF 08/677,218 07/09/1996 ABN
AND IS A CIP OF 08/680,913 07/12/1996 ABN

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**** FOREIGN APPLICATIONS VERIFIED:**

PG-PUB	<input type="checkbox"/> DO NOT PUBLISH	<input type="checkbox"/> RESCIND	ATTORNEY DOCKET NO
Foreign priority claimed 35 USC 119 conditions met Verified and Acknowledged Examiners's initials			000761/P11
TITLE : Method of tisin deposition using a chemical vapor deposition process			

U.S. DEPT. OF COMMERCE / PAT. & TM. PTO-436L (Rev. 12-94)

NOTICE OF ALLOWANCE MAILED		CLAIMS ALLOWED	
		Total Claims	Print Claim for O.G.
		DRAWING	
		Sheets Drawg.	Figs. Drawg.
		Print Fig.	
ISSUE FEE			
Amount Due	Date Paid		
		Application Examiner	
<input type="checkbox"/> TERMINAL DISCLAIMER		PREPARED FOR ISSUE	
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